

Electronic Acknowledgement Receipt

EFS ID:	1178689
Application Number:	10696615
Confirmation Number:	6846
Title of Invention:	Semiconductor memory devices having offset transistors and methods of fabricating the same
First Named Inventor:	Se-Jin Ahn
Customer Number:	20792
Filer:	D. Randal Ayers/Michele McMahan
Filer Authorized By:	D. Randal Ayers
Attorney Docket Number:	5649-1202
Receipt Date:	30-AUG-2006
Filing Date:	28-OCT-2003
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Application Type:	Utility
International Application Number:	

Payment information:

Submitted with Payment	no
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1		Response_5649_1202.pdf	814550	yes	28

	Multipart Description		
	Doc Desc	Start	End
	Amendment - After Non-Final Rejection	1	1
	Applicant Arguments/Remarks Made in an Amendment	2	6
	Translation of Foreign Priority Documents	7	28

Warnings:

Information:

Total Files Size (in bytes):	814550
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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.